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On

JANUARY 21, 2005

TOWNSEND and TOWNSEND and CREW LLP

By:

Eleanor J. Taylor

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE –
EXAMINING GROUP 2812**

PATENT

Attorney Docket No.: 016301-045600US

AMAT No.: 6381 DSM/PMD/JW

Client Ref. No.: A6381/T45600

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

ZHENG YUAN et al.

Application No.: 10/090,103

Filed: February 27, 2002

For: PROCESS FOR FORMING
SILICON OXIDE MATERIAL

Confirmation No. 4419

Examiner: Ron Everett Pompey

Technology Center/Art Unit: 2812

**AMENDMENT UNDER 37 CFR 1.116
EXPEDITED PROCEDURE EXAMINING
GROUP 2812**

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Sir:

In response to the Final Office Action mailed on the above-referenced application, please enter the following amendments and remarks. A petition for a one month extension of time for consideration of this amendment is included herein.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.